

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shinji Maekawa Art Unit : 2813
Serial No. : 09/724,403 Examiner : Stephen W. Smoot
Filed : November 27, 2000 Confirmation No.: 7575
Notice of Allowance Date: February 14, 2007
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE THAT
INCLUDES FORMING A MATERIAL WITH A HIGH TENSILE STRESS IN
CONTACT WITH A SEMICONDUCTOR FILM TO GETTER IMPURITIES
FROM THE SEMICONDUCTOR FILM (AS AMENDED)

MAIL STOP ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF ALLOWANCE

In response to the Notice of Allowance mailed February 14, 2007, enclosed are a completed issue fee transmittal form PTOL-85b and a check for \$1400 for the required issue fee and publication fee, including patent copies.

Please apply any additional charges or credits to our Deposit Account No. 06-1050.

Respectfully submitted,



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